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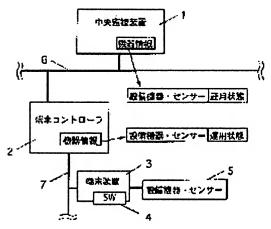
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(54) MONITORING CONTROL SYSTEM

(57)Abstract:

PROBLEM TO BE SOLVED: To provide a monitoring control system capable of easily confirming test operation of a sensor device and facility equipment without using an exclusive inspection device during the operation of the system.

SOLUTION: This monitoring control system performs monitoring control of terminal units 3 by a central monitoring device 1 by dispersing and installing the terminal units 3 in an object 5 to be monitored and controlled such as the sensor device and facility equipment. A switching means 4 switching setting of an operation mode operating the terminal units as at least a test condition is provided in the terminal units 3 as shown in Fig. 1, and the central monitoring device 1



excludes processing for interlocking the terminal units 3 with the other object 5' to be monitored and controlled when detecting that a setting condition of the operation mode by the switching means 4 is a test operation mode.

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